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#8
SP
501.40692X00

07-16-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): MIYAZAKI, et al

RECEIVED

Serial No.: 09/964,490

JUL 11 2003

Filed: September 28, 2001

Technology Center 2100

For: FABRICATION METHOD OF SEMICONDUCTOR
INTEGRATED CIRCUIT DEVICE

Group: 2812

Examiner: TBD

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 AND 1.98**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 9, 2003

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find copies of documents to be considered by the Examiner during examination of the above-identified application. Also enclosed are English translations of the respective documents. Further enclosed is a Form, substantially equivalent to Form PTO-1449, listing the enclosed documents.

This Information Disclosure Statement is being submitted prior to a first Office Action on the merits in the above-identified application. Accordingly, requirements of 37 CFR 1.97(b) are satisfied.

In any event, the following Statement is made under 37 CFR 1.97(e)(2):

No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making

reasonable inquiry, no item of information contained in this Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c), more than three months prior to the filing of this Information Disclosure Statement.

The documents, enclosed, listed on the enclosed Form, are not in English. For satisfying requirements of 37 CFR 1.98(a)(3), English translations of the listed documents are enclosed.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR § 1.97 and § 1.98 have been satisfied, in connection with the documents listed on the enclosed Form. Accordingly, consideration of the listed documents, upon examination of the above-identified application, is respectfully requested.

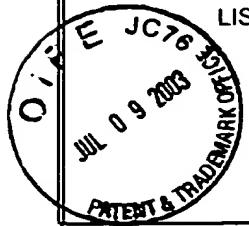
Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No. 01-2135 (Case No. 501.40692X00), and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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LIST OF ART CITED BY APPLICANT

(PTO-1449)

ATTY. DOCKET NO.
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APPLICANT
Miyazaki, et al.

FILING DATE
September 28, 2001

GROUP
2812

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	5-289307	11/5/93	Japan			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.